



Equipment for PV materials

Thin film technologies
PVD and PECVD coaters
Contract research

Equipment for PV materials PECVD and Thermal canon coating systems Meb and Coast and Systems Transparent contact layer Active layer Metal contact layer Web and Coating systems

Capabilities of the technologies

- Transparent conductive coatings TCO (ITO, ZnO, AZO or SnO₂) by magnetron sputtering with ceramic target and metal targets in quasireactive and reactive processes for transparent coatings
- Metal and alloy coatings (Cu, Ag, In, Ti, Ni, Mo, Cr, NiCr, St.St., NiCo etc.) by magnetron sputtering and thermal evaporation for metal contact and active layers coatings
- Oxides and nitrides (SiO₂, TiO₂, TiN, Si₃N₄ etc.) by magnetron sputtering with ceramic targets and metal targets in quasi-reactive and reactive process for antireflection, moisture-proof, and other protection coatings
- Preliminary drying by heating technique
- Plasma pretreatment by glow discharge and ion sources
- Vacuum lamination of web substrates

Capabilities of the equipment

- Roll-to-roll coaters for metal and non-metal webs
- In-line sputtering systems for glass sheet
- PECVD coaters for amorphous silicon deposition
- Drying machines
- Vacuum laminators
- Customized vacuum coating systems

Substrates

- Polymer materials:
 - width 0.3 to 2.0 m
 - thickness 25 to 300 μm
- Metal foils:
 - width 0.15 to 1.5 m
 - thickness 10 to 100 μm
- Glass: size up to 2.5 m x 3.5 m
- Powder materials: size 30 to 800 μm

Web coater P600MR



PECVD web coater



Glass in-line sputtering coater



Powder coater



